



Docket No. 740819-617

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	
Kenji ORITA et al.	)	Group Art Unit: 2814
Serial No. 09/986,997	)	Examiner: Long Pham
Filed: November 13, 2001	)	
For: METHOD OF FABRICATING SEMICONDUCTOR	)	Confirmation No.: 6386
DEVICE HAVING GROUP III NITRIDE	)	

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1540  
Alexandria, Virginia 22313-1450

Sir:

In response to the final Office Action mailed September 21, 2004, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** being on page 3 of this paper.